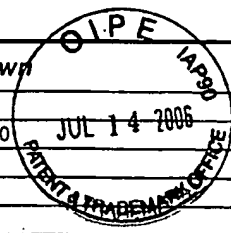


IDS Form PTO/SB/08: Substitute for form 1449A/PTO		Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(Use as many sheets as necessary)</i>		Application Number	09/487,483
		Filing Date	January 19, 2000
		First Named Inventor	Masue SHIBA
		Art Unit	2134
		Examiner Name	M. Simitoski
		Attorney Docket Number	04329.2217
Sheet	1	of	1



U.S. PATENTS AND PUBLISHED U.S. PATENT APPLICATIONS					
Examiner Initials	Cite No. ¹	Document Number	Issue or Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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Note: Copies of the U.S. Patent Documents are not Required in IDS filed after October 21, 2004

FOREIGN PATENT DOCUMENTS						
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		Country Code ³ Number ⁴ Kind Code ⁵ (if known)				
MS		JP-10-153956	06-09-1998			

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	Translation ⁶
MS		Decision of Rejection mailed on May 30, 2006, from Japanese Patent Office in Japanese Patent Application No. 11-011989.	Yes
MS		Decision of Rejection mailed on June 6, 2006, from Japanese Patent Office in Japanese Patent Application No. 11-209831.	Yes
MS		NAOYA TORRI et al. "Trial of Elliptic Curve Cipher Chip," IEICE Engineering Sciences Society Convention, September 7, 1998, p. 115.	

Examiner Signature	/Michael Simitoski/	Date Considered	12/11/2006
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.